APPROVAL

DETERMINATION OF THE HARDNESS DISTRIBUTION PATTERN OBTAINED BY NITRIDING WITH A PLASMA FOCUS DEVICE

by

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DECLARATION

I, the undersigned, hereby declare that this report is my own independent work except as specified in the references and acknowledgements. I have not committed plagiarism in the accomplishment of this work, nor have I falsified and/or invented the data in my work. I am aware of the University regulations on Plagiarism. I accept the academic penalties that may be imposed for any violation.

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ABSTRACT

Plasma focus nitriding is one of the case-hardening method which utilizes energetic bombardment of nitrogen ion beam, produced through high temperature due to electrical discharge at high voltage, onto the target material surface. Experiment was carried out by nitriding low carbon steel samples AISI 1020 using different combination of nitrogen pressure (0.5 Torr, 1.0 Torr, 1.5 Torr, 2.0 Torr) and sample distance from anode tip (40 mm, 60 mm, 80 mm, 100 mm, 120 mm), by using UNU/ICTP PFF plasma focus device which was charged initially at 12 kV. Each sample was fired by 30 shots of nitrogen ion beam. The result showed that the plasma focus nitriding produced a localized hardening region near the epicentre of plasma pinch, with diameter ranged between 15 mm - 30 mm. The maximum Vickers microhardness measured was 429.1 HV 0.2, at nitrogen pressure of 1.0 Torr and distance from anode of 40 mm. Layering ring-like pattern was observed on the nitrided steel surface. Samples closer to the anode tip (40 mm to 60 mm) exhibited localized rough surface near epicentre, which coincided with the localized hardening region. Radiative Dense Plasma Focus Computation Package (RADPF) software - Lee model code was implemented to generate nitrogen beam related parameters using differential current waveform obtained experimentally. Model fitting and numerical simulation result showed that the optimum plasma focusing in nitrogen environment took place at around 1.0 Torr - 1.5 Torr,

DEDICATION

This thesis is dedicated to my parents, Ng Boon Shyong & Tan Geok Kiow.

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LIST OF ABBREVIATIONS

DPF Dense Plasma Focus

RADPF Radiative Dense Plasma Focus

MHD Magnetohydrodynamics

AC , Alternating Current

NOMENCLATURE

	ŧ
Symbol	Definition
h	Planck's constant ($6.63 \times 10^{-34} \text{ J s}$)
v	Frequency of photon [Hz]
n_i	Density of ionized atoms [m ⁻³]
n_n	Density of neutral atoms [m ⁻³]
T	Gas temperature [K]
k	Boltzmann's constant (1.38 \times 10 ⁻²³ J K ⁻¹)
U_i	Ionization energy of gas [J]
n _e	Electron density [m ⁻³],
n_z	Z-times charged ion density [m ⁻³]
E_{av}	Average kinetic energy [J]
f	Degree of freedom of gas molecule
E	Electric field [N C ⁻¹]
k	Coulomb's constant $(9.0 \times 10^9 \text{ N m}^{-2} \text{ C}^{-2})$
Q, q	Electrical charge [C]
r	Distance length [m]
F	Coulomb force [N]
p	Kinetic pressure of plasma [Pa]
p_{m0}	Magnetic pressure at plasma surface [Pa]
B_0	Magnetic flux density at plasma surface [T]
μ_0	Vacuum permeability $(4\pi \times 10^{-7} \text{ T m A}^{-1})$
I, i	Current [A]
A	Cross-sectional area of Rogowski coil [m²]
n	Number of turns per unit circumferential length [m ⁻¹]
$d_{I,2}$	Diagonal length of Vickers indentation [mm]
d	Arithmetic mean of diagonal lengths [mm]
F	Indentation test force [N]
HV	Vickers hardness
α	Angle between opposite faces of pyramidal indenter

CHAPTER 1

INTRODUCTION

1.1. Background

In the daily operation of complicated machines, there is one factor that is difficult to be eliminated and unavoidably causes failure in machines – friction. Friction may come into serious negative effects like surface wearing when improper or lack of lubrication is implemented. In order to improve the wear resistance of machine parts without affecting the interior bulk material properties of the parts, a process called "surface hardening" is introduced and applied by means of a wide variety of mechanisms.

Surface hardening process is very useful in machinery parts such as cams, bearings, shafts, turbine applications and automotive components. These types of machinery parts require high surface hardness to resist wearing, while maintaining tough interior strength to withstand forces applied when the relevant machines are operating (Dossett & Totten, 2013).

Surface hardening has a wide engineering application in several practical aspects, such as the safety concerns in building or bridge construction, machineries components. Mechanical wear may be accelerated by chemical damage to the worn materials. The collapse of Mianus River Bridge in Greenwich, Connecticut, USA in 1983 was one of the disastrous tragedies in engineering history due to the reason of metal corrosion and wearing. This tragedy caused four people killed and five people injured during the collapse (Ben-Daya, Kumar, & Prabhakar, 2016). Similar engineering tragedies has introduced the highlights and considerations of issues in mechanical wearing and surface hardness as one of the factors to ensure that the structural design is successful and has no potential safety hazards to relevant people.

Dense plasma focus device (PDF) is an unconventional plasma device which has the capability of producing X-rays, neutrons, relativistic electrons and energetic ion beams. These are essentially very useful in some applications, for example surface treatment,

thin layer deposition, sputtering and modification of materials. By mean of implementing the dense plasma focus device, the surface material properties of the target specimen like hardness, corrosion and wear resistances can be altered and controlled through surface coating process (Al-Hawat, Soukieh, Kharoub, & Al-Sadat, 2010).

1.2. Problem Statements

The dominant concern in the surface coating process of dense plasma focus device is that, the surface hardening effect is not the same at various distances from epicentre. The effectiveness of hardness improvement is varying at different surface locations on the coated specimen. There may be cases when the hardness near the epicentre is sufficient, but the hardness at a further distance away is below specification.

Due to this reason, it is required to understand the relationship between the surface strengthening effect and the distance to plasma shot epicentre, to ensure that the surface hardness of the coated surface can withstand the forces exerted onto the surface at all times without resulting in surface wearing.

In order to carry out investigation for this Final Year Project, a Mather-type 3 kJ DPF device was implemented to perform the plasma treatment on the target AISI 1020 low carbon steel samples.

1.3. Objectives of the Research

The overall objectives of the research can be as follows:

- To investigate and develop the hardness distribution pattern of nitriding using Mather-type 3 kJ DPF device (UNU/ICTP PFF) through experiments.
- To analyse and identify the relevant factors affecting the hardness distribution pattern.
- To determine the optimum condition of plasma focusing in nitrogen-filled environment experimentally and numerically.

1.4. Scope of the Research

In Final Year Project Stage 1, due to the limitations of time constraints raised from the open timeslots of workshop and material laboratory, AISI 1020 steel material samples preparation such as material bar cutting, milling, grinding, hardness measuring and literature review research were more focused in this stage.

The Stage 2 was more focused on the experimental nitriding process by using UNU/ICTP PFF device, and analysis of the experimental results to study the effect of distance from the epicentre of the target on the amount of hardening in a PF device. Radiative Dense Plasma Focus Computation Package (RADPF) a.k.a. Lee model code was also implemented to perform computational simulations for the correlation with experimental results. The effect of surface hardening was correlated to the number of ions produced during plasma nitriding, which values were obtained through current model fitting and computational simulation using Lee model code.

1.5. Report Organization

This Final Year Project Interim Report covers the following aspects:

- Chapter 2: Literature Review
 - Characteristics and properties of fourth state of matter plasma.
 - Operation of Dense Plasma Focus (DPF) device.
 - Related mechanical properties of AISI 1020 low carbon steel required for samples preparation.
 - Method of Vickers hardness testing, as of ISO 6507-1:2005 required.
- Chapter 3: Methodology
 - Method to fabricate required steel samples.
 - o Parameters and dimensional decisions of certain processes.
 - o Procedures of operating DPF device.
 - Implementation of Lee model code for numerical simulation of plasma pinching process.
- Chapter 4: Experimental Results
 - Hardness distribution comparison between nitrided and unnitrided steel.

- O Layering pattern appearance on nitrided steel surface.
- o Correlation between hardening region and layering pattern.
- O Numerical ion beam analysis using Lee model code.
- O Correlation between experimental and numerical results.

• Chapter 5: Conclusion

- O Summarization of overall project.
- o Relation between plasma nitriding and real life engineering application.
- o Recommendation on related project.
- Possible future work ahead.